

BOX AF
RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINER GROUP 2851

03560.002558.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Examiner: H. Nguyen

Yuji SUDOH et al.

Of roup Art Unit: 2851

Application No.: 09/532,022

Filed: March 21, 2000

For: EXPOSURE APPARATUS AND A
DEVICE MANUFACTURING METHOD:
WHICH KEEP TEMPERATURE OF A
DIAPHRAGM OF A PROJECTION
OPTICAL SYSTEM SUBSTANTIALLY
CONSTANT

Examiner: H. Nguyen

OF A Unit: 2851

August 12, 2002

OF A Unit: 2851

OF CONSTANT

DIAPHRAGM OF A PROJECTION
OPTICAL SYSTEM SUBSTANTIALLY
CONSTANT

AMENDMENT AFTER FINAL REJECTION WITH PETITION FOR EXTENSION OF TIME

Sir:

Box AF

Applicants petition the Commissioner for Patents to extend the time for response to the

Office Action dated March 12, 2002, for two months from June 12, 2002, to August 12, 2002. A

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The Commissioner for Patents

Washington, D.C. 20231

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